


<b>Search Notes</b>  	<b>Application/Control No.</b>  10626040	<b>Applicant(s)/Patent Under Reexamination</b>  LEBNER, MICHAEL
	<b>Examiner</b>  Lewis, Kim M	<b>Art Unit</b>  3772

SEARCHED			
Class	Subclass	Date	Examiner
602	41-43,52,54,57-59	5/23/07	kml
606	213-216		
updated search: same as above		2/18/08	kml

SEARCH NOTES		
Search Notes	Date	Examiner

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner